PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
DA SOON LEE	10/28/2013
HYUNG SUK CHOI	10/28/2013
JEONG GYU PARK	10/28/2013
GIL HO LEE	10/28/2013
HYUN TAE JUNG	10/28/2013
MENG AN JUNG	10/28/2013
WOO SIG MIN	10/28/2013
PIL SEUNG KANG	10/28/2013

RECEIVING PARTY DATA

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PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	14067335

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ATTORNEY DOCKET NUMBER: 023103.0089 PATENT

502551717 REEL: 031511 FRAME: 0852

NAME OF SUBMITTER:	S. LAURA CHUNG	
Signature:	/S. Laura Chung/	
Date:	10/30/2013	
Total Attachments: 3 source=NewApp_0231030089_CDAwAppNumber#page1.tif source=NewApp_0231030089_CDAwAppNumber#page2.tif source=NewApp_0231030089_CDAwAppNumber#page3.tif		

PATENT REEL: 031511 FRAME: 0853

COMBINED DECLARATION AND ASSIGNMENT UNDER 37 CFR 1.63(e)

DECLARATION

As a below-named inventor, I hereby declare that this declaratio	in is directed to the application attached hereto
or to United States Application Number or PCT International Application	plication Number
filed on	(if applicable), entitled:

SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

The above-identified application was made or authorized to be made by me.

I believe I am the original inventor or an original joint inventor of a claimed invention in the above-identified application.

I hereby acknowledge that any willful false statement made in this declaration is punishable under 18 USC 1001 by fine or imprisonment of not more than five (5) years, or both.

I have reviewed and understand the contents of the above-identified application, including the claims.

I am aware of the duty to disclose to the United States Patent and Trademark Office all information known to me to be material to patentability as defined in 37 CFR 1.56, including for continuation-in-part applications, material information that became available between the filing date of the prior application and the national or PCT international filing date of the continuation-in-part application.

ASSIGNMENT

For valuable consideration, I, as a below-named assignor, hereby assign to:

MagnaChip Semiconductor, Ltd.

1 Hyangjeong-dong, Heungdeok-gu,
Cheongju-si, Chungcheongbuk-do, 361-728
Republic of Korea

and its successors and assigns (collectiv	vely hereir	nafter called "the Assignee"), the entire right, title, and
		improvements that are the subject of the application
		States Application Number or PCT International Application
		October 30, 2013

I authorize and request the attorneys appointed in the above-identified application to hereafter complete this Assignment by inserting above the application number and the filing date of the above-identified application when known, and to correct any typographical errors that may be discovered in this Assignment.

This Assignment includes the above-identified application, any and all United States and foreign patents, utility models, and design registrations granted for any of the inventions and improvements that are the subject of the above-identified application, and the right to claim priority based on the filing date of the above-identified application under the International Convention for the Protection of Industrial Property, the Patent Cooperation Treaty, the European Patent Convention, and all other treaties of like purposes; and I authorize the Assignee to apply in all countries in my name or in its own name for patents, utility models, design registrations, like rights of exclusion, and inventors' certificates for any of the inventions and improvements that are the subject of the above-identified application; and I agree for myself and my heirs, legal representatives, and assigns without further compensation to perform such lawful acts and to sign such

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COMBINED DECLARATION AND ASSIGNMENT UNDER 37 CFR 1.63(e)

further applications, Assignments, preliminary statements, and other lawful documents as the Assignee may reasonably request to effectuate fully this Assignment.

In witness whereof, I, as a below-named inventor and assignor, intending to be legally bound, have hereunto affixed my signature on the date indicated below next to my signature.

Inventor's Legal Name	LEE, Da Soon		
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COMBINED DECLARATION AND ASSIGNMENT UNDER 37 CFR 1.63(e)

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